



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 8304**
Takashi MAEDA et al. : Attorney Docket No. 2005_0059A
Serial No. 10/523,262 : Group Art Unit 3709
Filed March 3, 2005 : Examiner Michael Thomas Hess

METHOD AND APPARATUS FOR
MOUNTING COMPONENTS

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement of January 23, 2007, Applicants hereby elect Group I, which is drawn to a method and apparatus for mounting components that detects whether or not a nozzle for picking up a component fails to pick up the component at the component pick up stage and is embodied by claims 1-6.

Having made the required election, a full examination on the merits of the elected group is requested.

Respectfully submitted,

Takashi MAEDA et al.

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THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975